

Notice of References Cited	Application/Control No. 09/695,414	Applicant(s)/Patent Under Reexamination ZHANG ET AL.	
	Examiner Evan Pert	Art Unit 2826	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-4,951,601	08-1990	Maydan et al.	118/719
	B	US-3,617,373	11-1971	Mott, James H.	216/17
	C	US-2,450,850	10-1948	COLBERT WILLIAM H; et. al.	427/166
	D	US-2,414,406	01-1947	COLBERT WILLIAM H; et. al.	118/730
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	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Maissel et al., Handbook of Thin Film Technology, McGraw-Hill Book Company, 1970, pages 7-2 to 7-4.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.